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6-27-01

Docket No.: M-10693 US

June 26, 2001

06/26/01  
09/89 1693  
J1033 U.S. PTO

Box Patent Application  
Commissioner For Patents  
Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventors: Steve Biellak, Stanley E. Stokowski and Mehdi Vaez-Iravani  
 Title: SYSTEMS AND METHODS FOR A WAFER INSPECTION SYSTEM USING  
MULTIPLE ANGLES AND MULTIPLE WAVELENGTH ILLUMINATION  
X Return Receipt Postcard  
X This Transmittal Letter (in duplicate)  
14 pages Specification (not including claims)  
8 pages Claims  
1 page Abstract  
3 Sheets of Drawings  
4 pages Declaration For Patent Application and Power of Attorney  
1 page Recordation Form Cover Sheet (in duplicate)  
2 pages Assignment  
3 pages Information Disclosure Statement and PTO Form 1449 citing 21 references  
 Copies of 21 Cited References submitted

**CLAIMS AS FILED**

For	Number Filed	Number Extra	Rate	Basic Fee
Total Claims	45	-20 = 25	x \$ 18.00	\$ 710.00
				\$ 450.00
Independent Claims	4	-3 = 1	x \$80	\$ 80.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application				\$ _____
<input type="checkbox"/> Fee for Request for Extension of Time				\$ _____

Please make the following charges to Deposit Account 19-2386:

Total fee for filing the patent application in the amount of \$ 1,240.00  
 The Commissioner is hereby authorized to charge any additional fees which may be  
required, or credit any overpayment to Deposit Account 19-2386.

EXPRESS MAIL LABEL NO:

EL707910583US

Respectfully submitted,

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